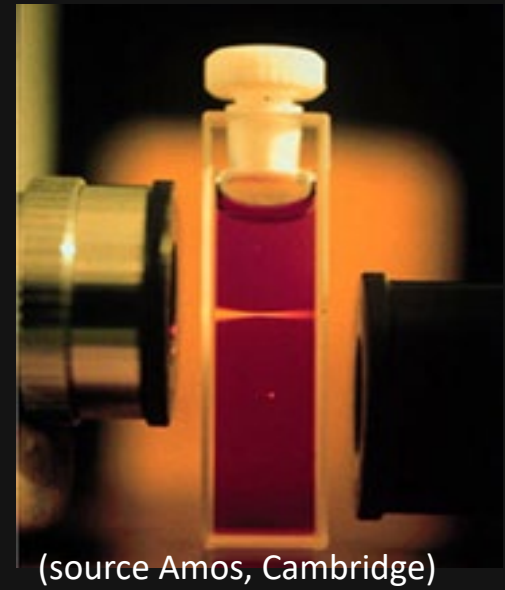
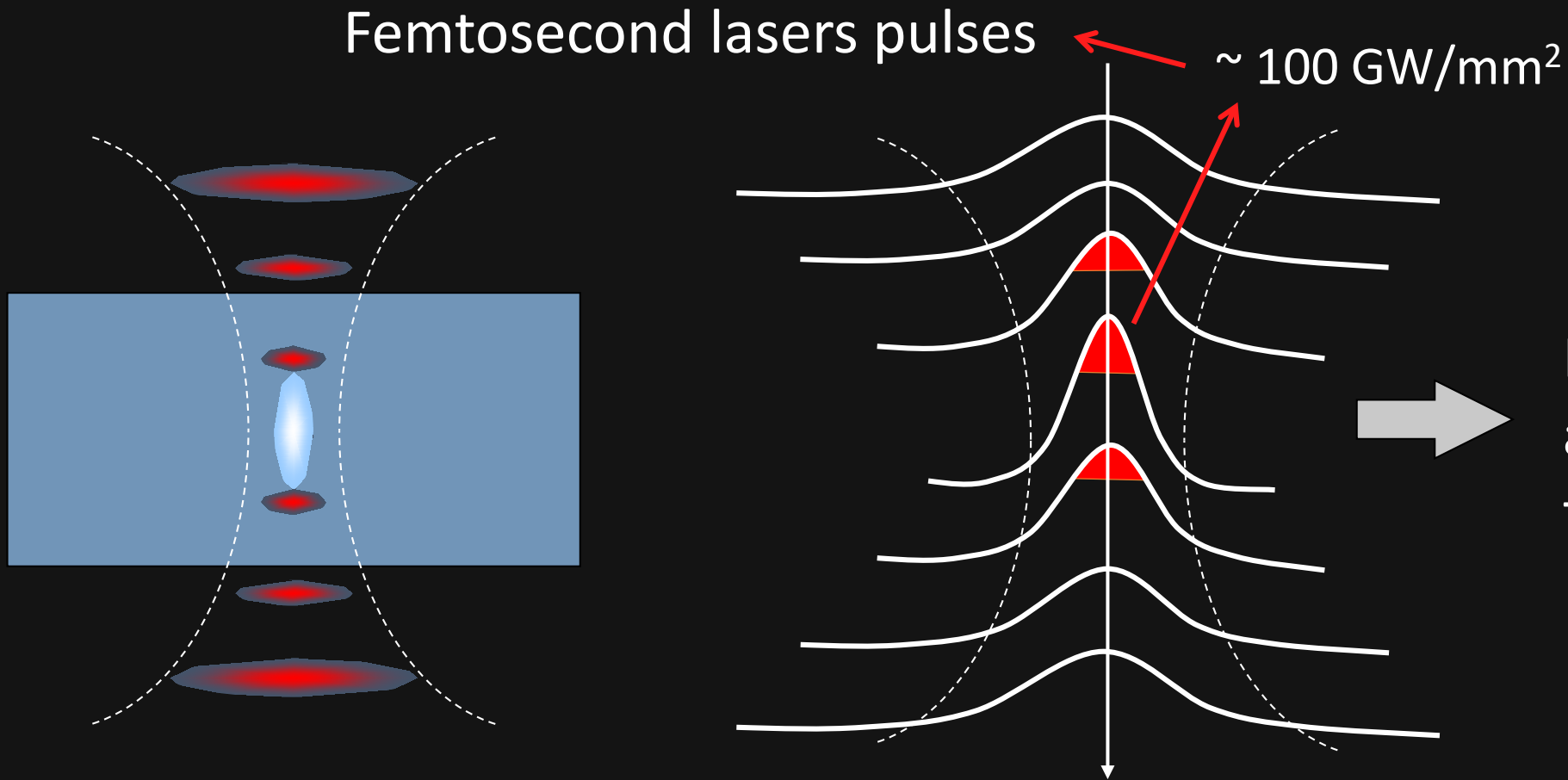


Ultrafast Laser Closed-loop Manufacturing using mid-IR Spectroscopy

Yves Bellouard

Non-linear absorption

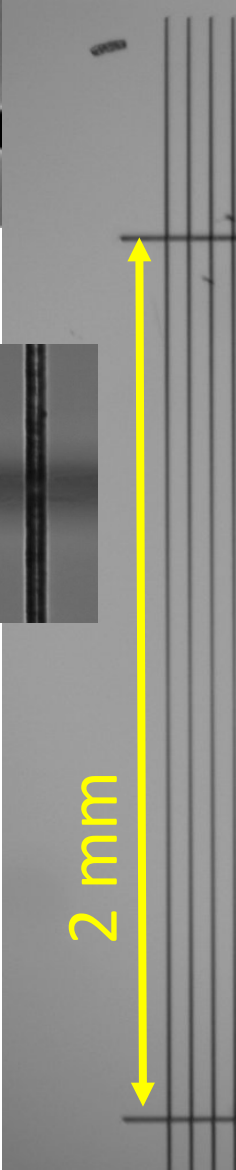
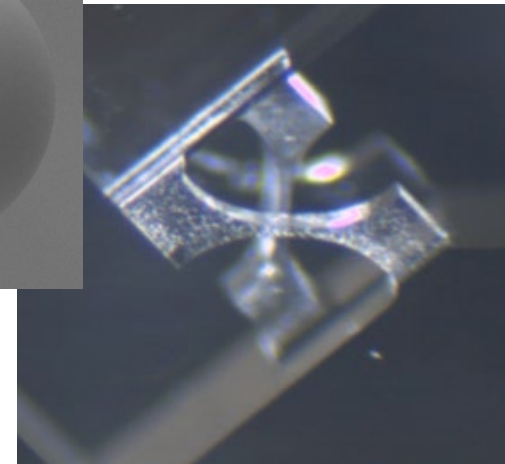
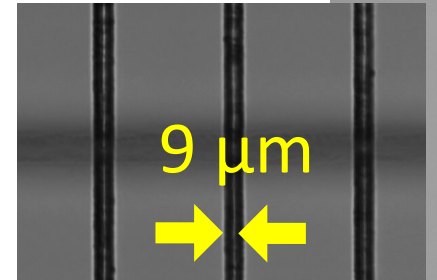
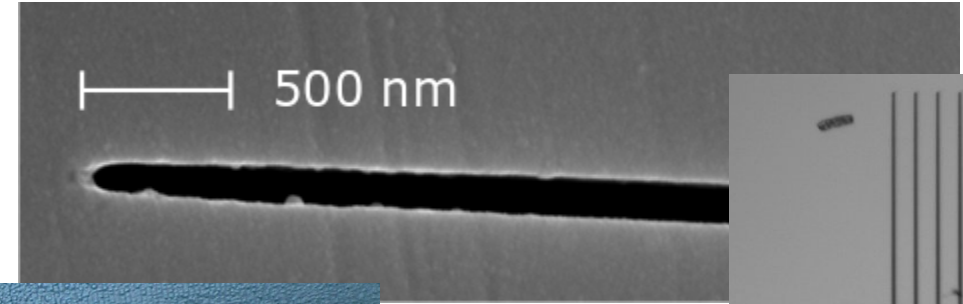
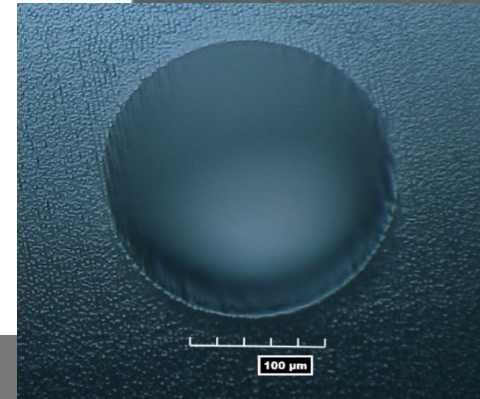
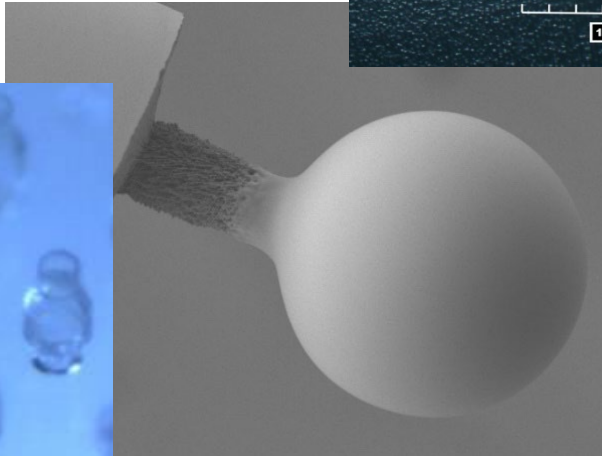
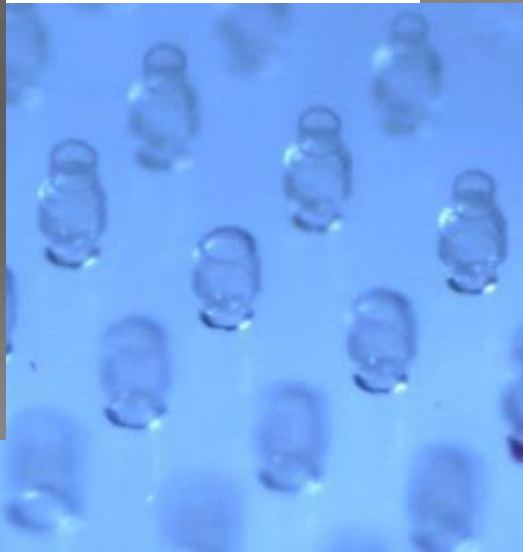
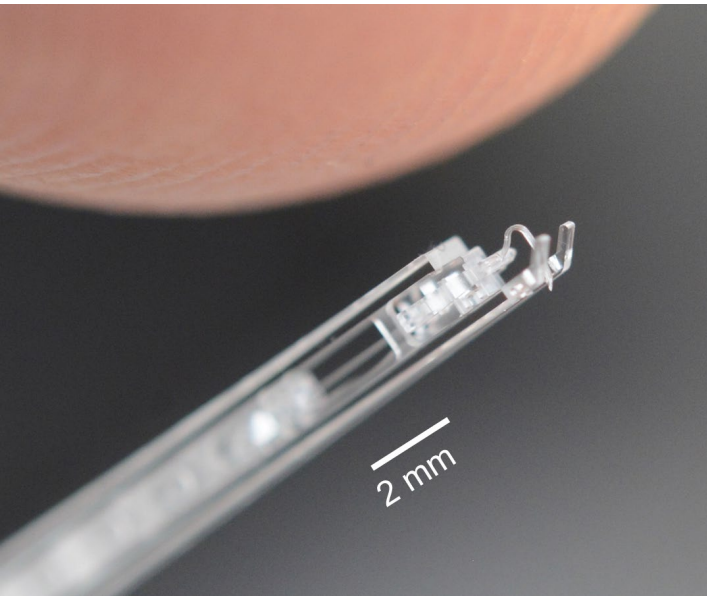


(source Amos, Cambridge)

In a transparent material, energy can be absorbed in the volume

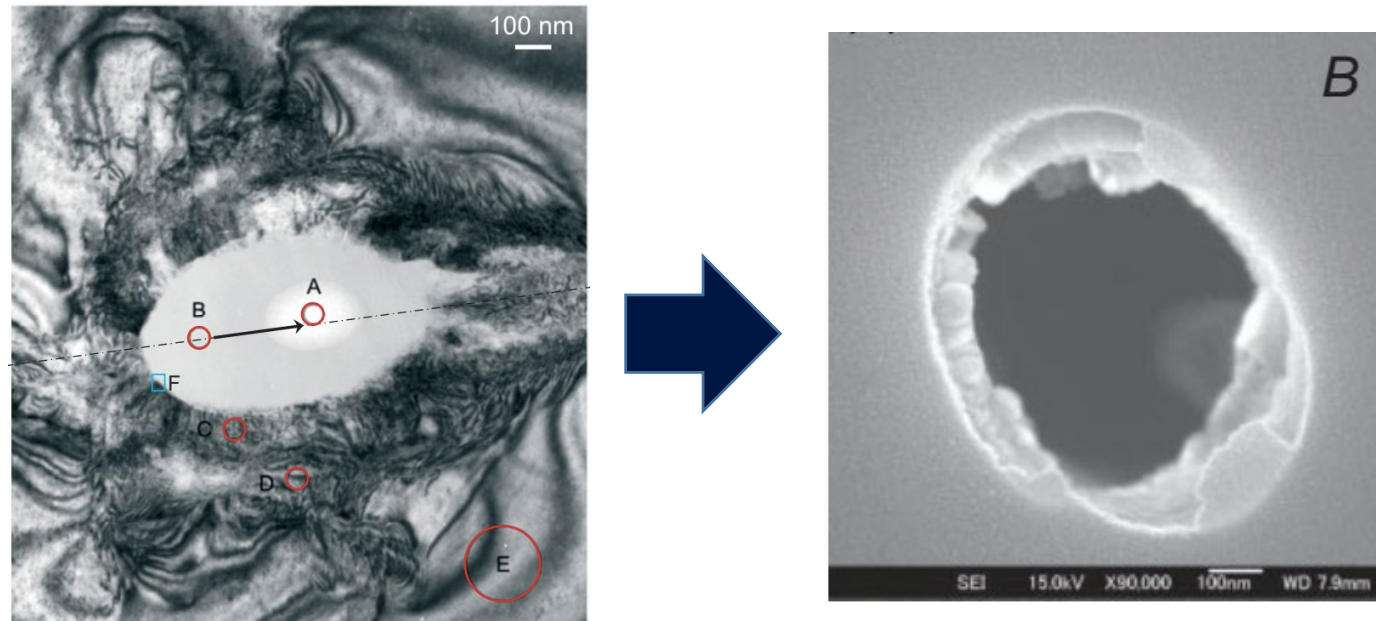
Femtosecond laser processing

- **Beyond diffraction limit:** nanoscale resolution (non-linear absorption process triggered by multi-photon processes)
- **High-aspect ratio** after etching ($>1:300$)
- Arbitrary **3D shapes**
- Scalable



Future prospects: how to go further?

1. Expand these processes to other key engineering materials (e.g. sapphire, aluminosilicate, mid-IR materials, etc.)
2. Controlled formation of crystalline phases in dielectrics / amorphous state in crystals



Teams



Yves Bellouard (Project coordinator), Ernesto Gribaudo, Benedikt Hermann, (Gözden Torun, Ruben Ricca)



Luka Emmenegger (PI), Matthew Singleton, Michele Gianella, Bela Tuzson



Jérôme Faist (PI), Mathieu Bertrand



Christoph Bostedt (PI), **Rasmus Ishebeck** (co-PI), Daniel Groliemund, Dario Ferreira Sanchez

Project objectives

Objective 1: to demonstrate **in-situ** sensing of **structural** modifications in realistic laser manufacturing conditions.

Objective 2: to develop a compact and **ultrafast mid-IR dual comb** sensing instrument compatible with a laser manufacturing setup.

Objective 3: to benchmark **dynamic information** during processing with data acquired during direct observations at SLS and SwissFEL.

Objective 4: to implement a **feedback control** on a laser-processing representative case study.

To provide industry with a manufacturing platform concept able to achieve unprecedented control on laser-exposed material properties with unmatched accuracy and reproducibility.

WP 1 / From fundamental processes to operando conditions, correlation of IR fingerprints with X-ray investigations (PSI, Empa, EPFL)

- 1.1. Static comparison of representative specimens
- 1.2. Dynamic processes of a single pulse to pulse train from the femtosecond timescale to equilibrium
- 1.3. Operando characterization and correlation to IR



Empa

Materials Science and Technology

ETH zürich

WP 3 / Demonstration activities using a tabletop system (EPFL, Empa, ETHZ)

- 3.1. Portable laser platform with embedded mid-IR sensing capabilities
- 3.2. Close-loop algorithm implementation
- 3.3. Demonstration on representative laser-induced structural transformations

Specifications

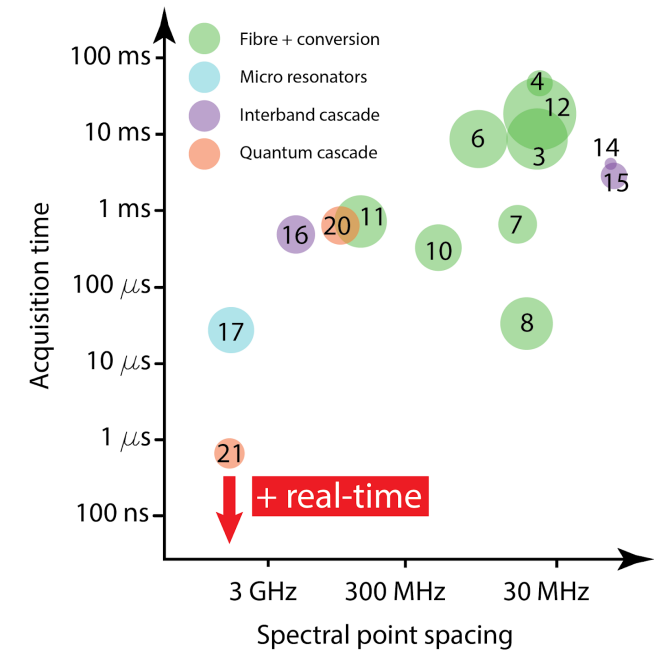
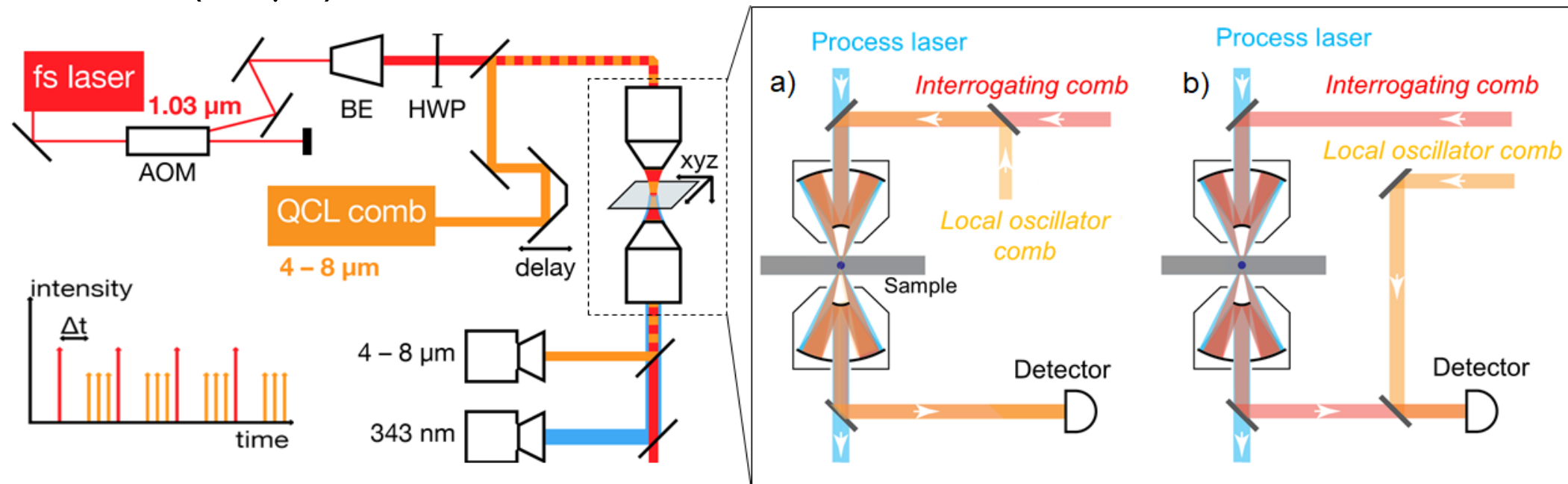
Miniaturized mid-IR comb-array

WP 2 / Compact Mid-IR dual comb sensing (Empa, ETHZ, EPFL)

- 2.1. Fabrication of laser devices with suitable repetition rate and center frequency
- 2.2. Third generation devices using integrated optic components
- 2.3. Fast dual-comb spectrometer
- 2.4. Second generation fast spectrometer with 100% duty cycle and 100 ns temporal resolution

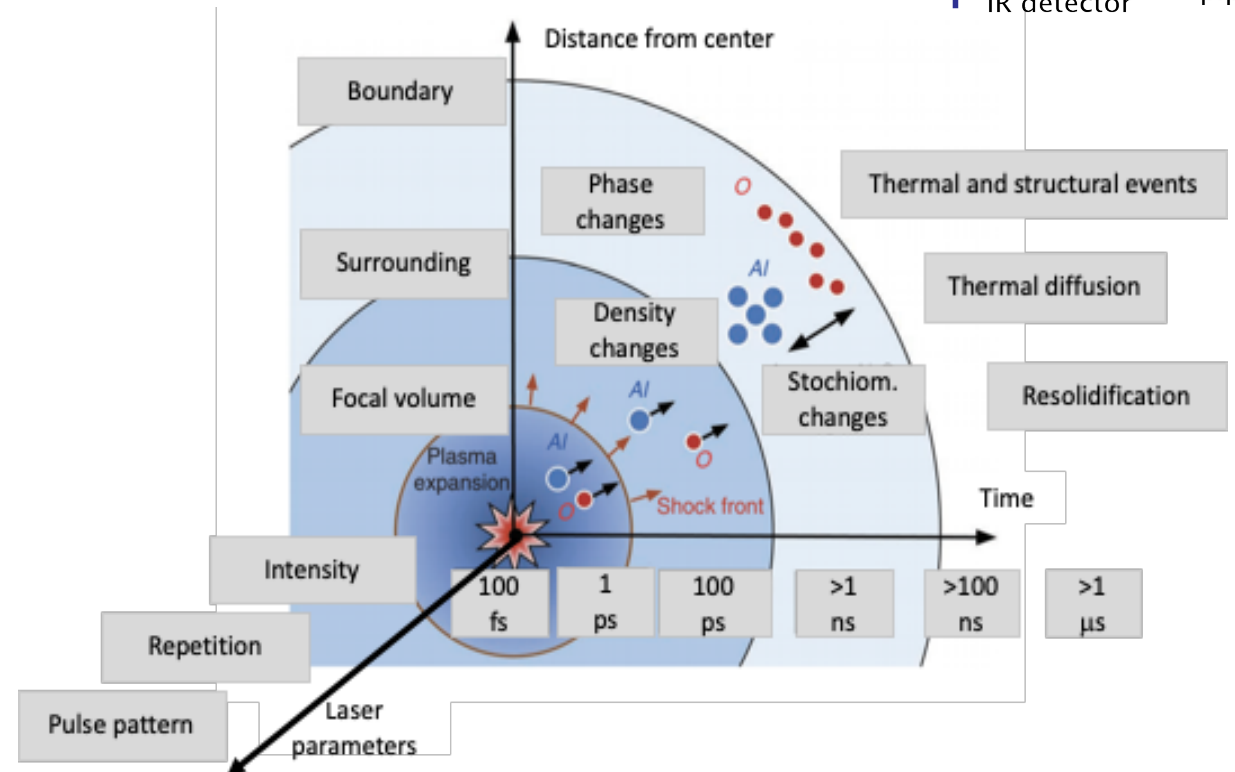
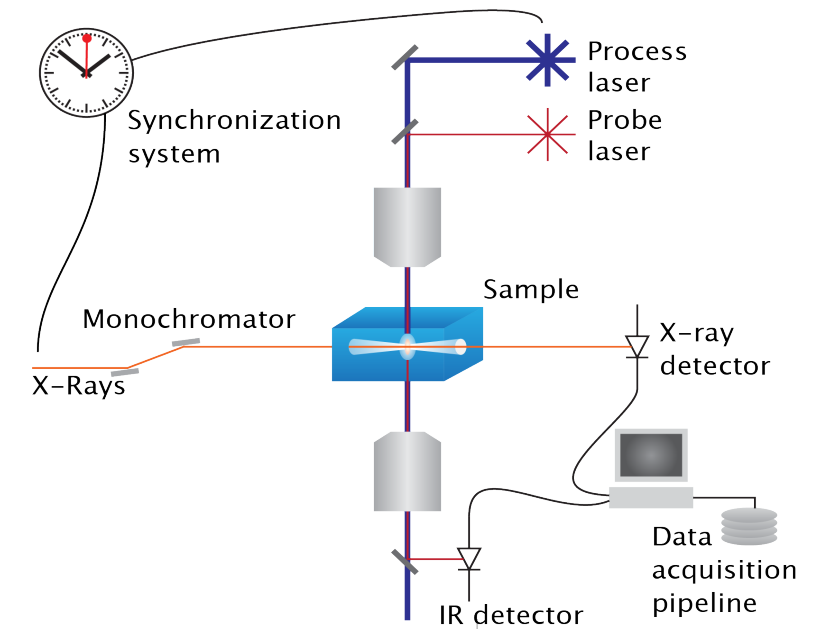
In-situ dual-comb mid-IR spectroscopy

- 'Convert optical absorption signal into radio frequency signal'
- In-situ
- Use of Quantum Cascade Lasers (QCL) for mid-IR
- Non-scanning spectroscopy method (unlike FTIR)
- Fast ($< 1\mu\text{s}$)



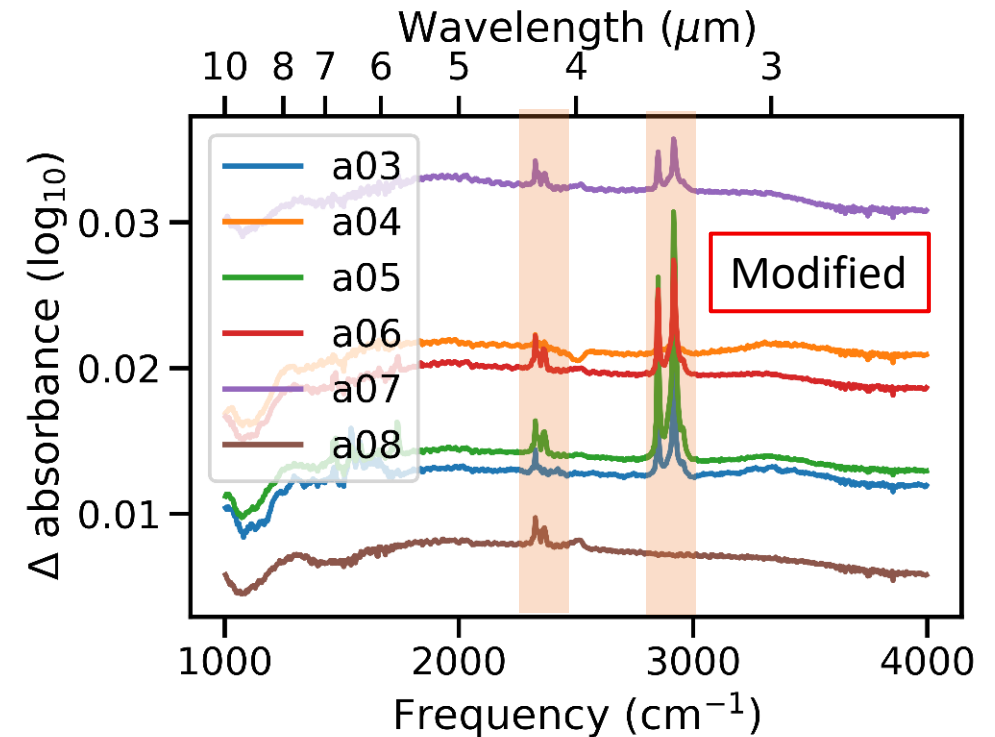
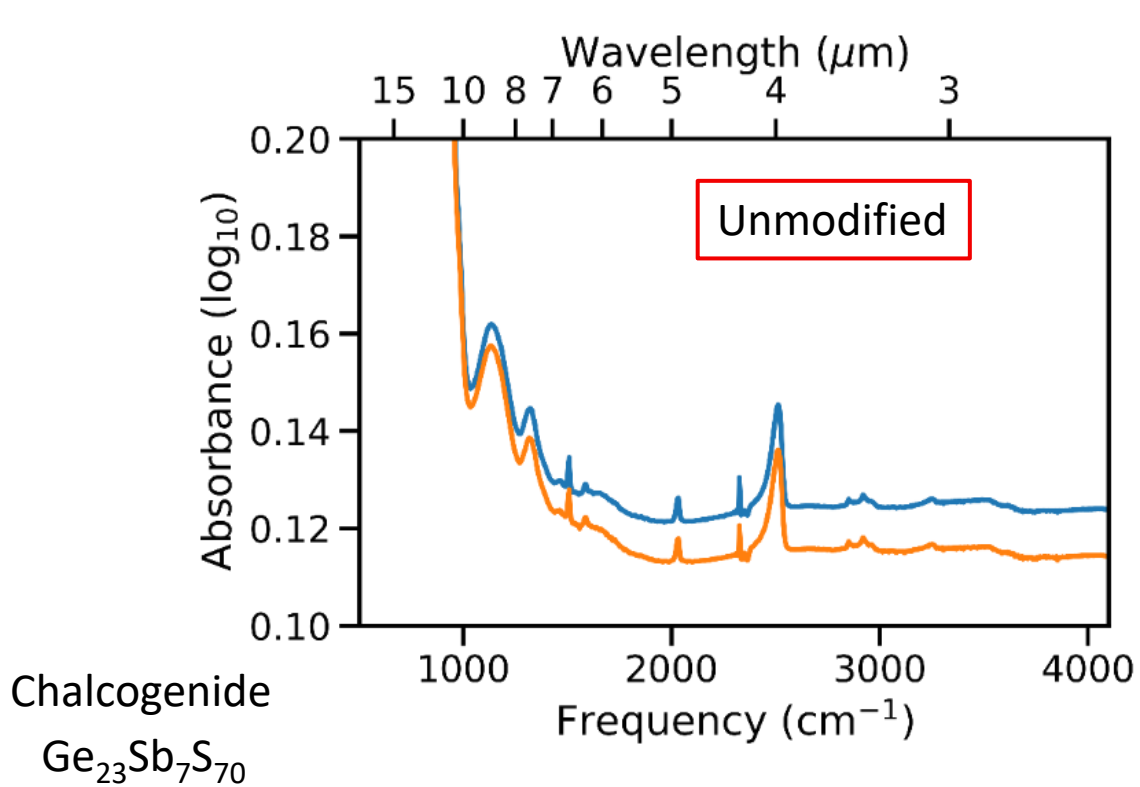
Benchmark dynamic observations

- When to look? What are important information to capture?
- Requires both temporal and high spatial resolution (XFEL)
- In-situ experiments (XFEL) / (SLS)

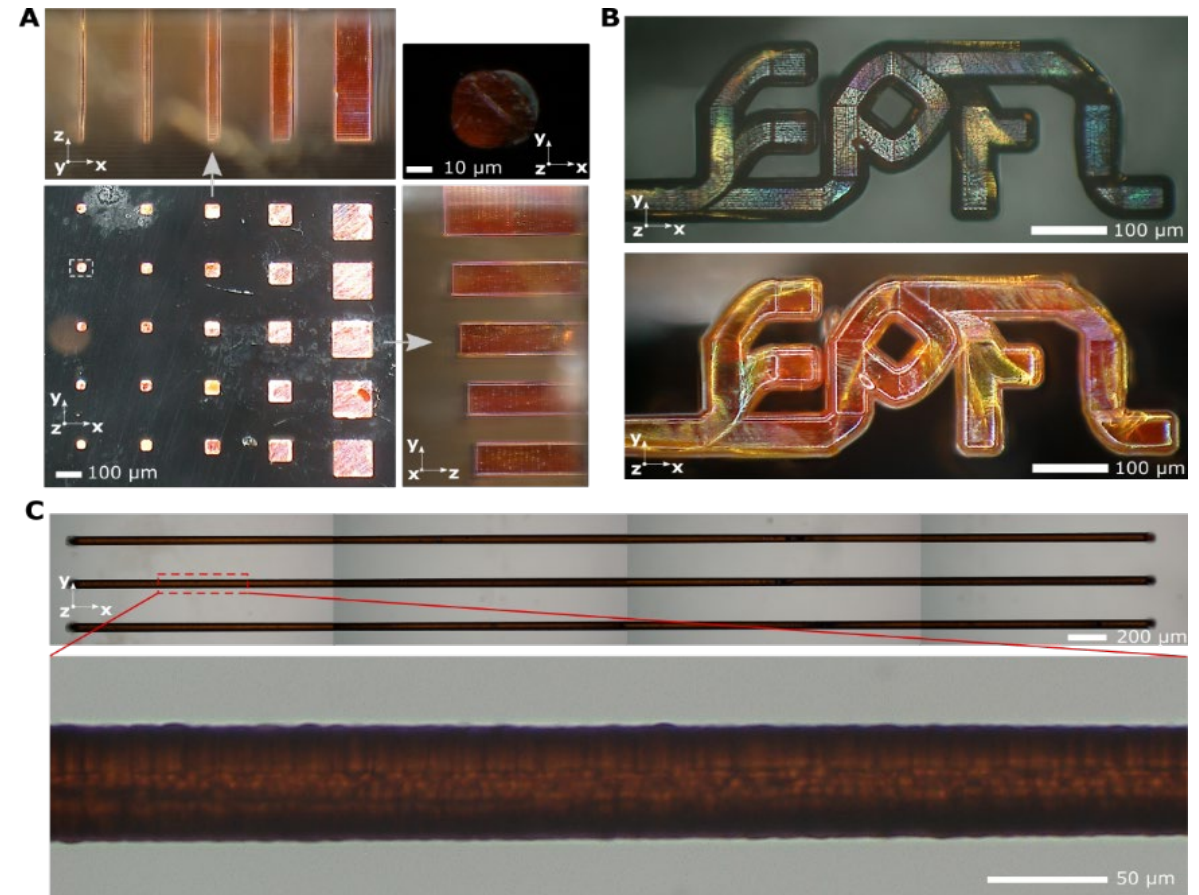
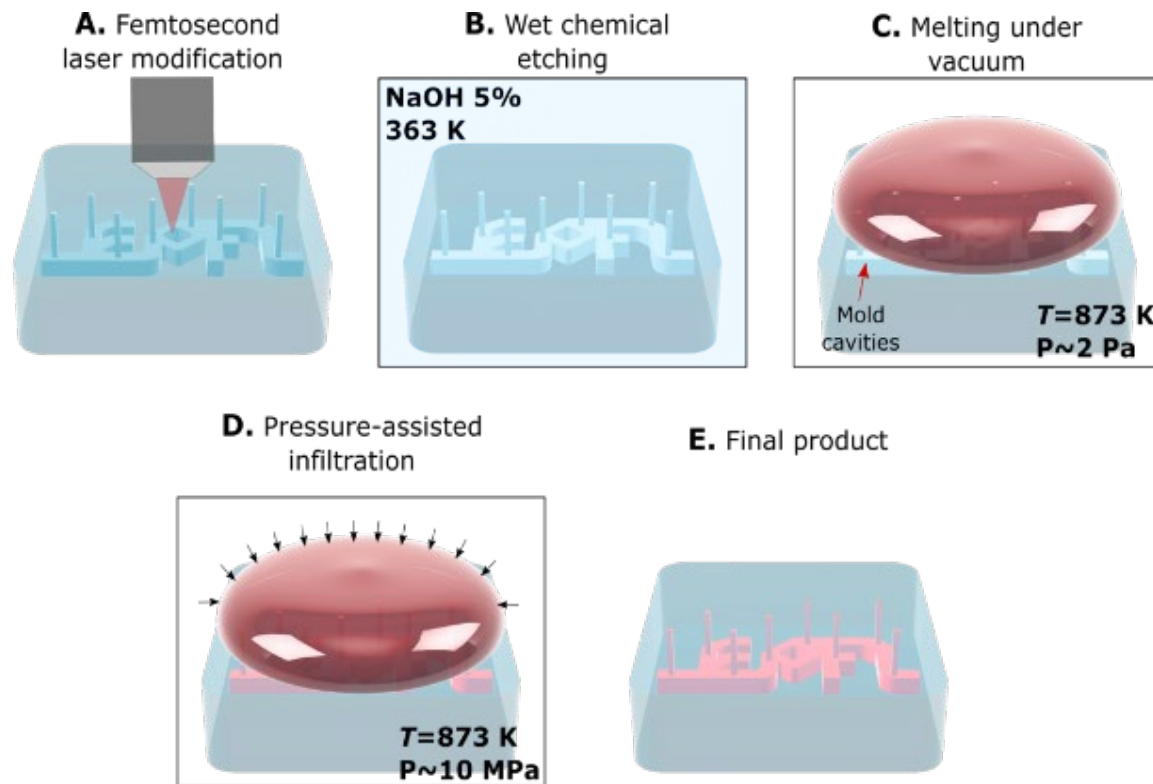


Progress to date

- Acquisition of FT-IR spectroscopic data of various laser-modified materials (fused silica, chalcogenide glass, sapphire)
- Production of first QCL combs
- First observations at the SLS observations on sapphire and other candidate materials
- Planning for the in situ platform for observation at the XFEL



A (very) recent highlight... Infiltration of mid-IR glass in a fused silica mold... Glass-in-glass composites



Thanks!

EPFL

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PSI